

Publikationen

Christine Wünsche, Rolf Rascher, Patrick Schäfer (2015): Quantification of synthetic lens surface characteristics by an optical measurement system as stylus instrument. In: Proceedings of SPIE 9442.

Christine Wünsche, Rolf Rascher, Patrick Schäfer: Quantification of synthetic lens surface characteristics by an optical measurement system as stylus instrument. In: Optics and Measurement International Conference 2014, Liberec, Tschechische Republik.